10681116 CLS

Most Frequently Occurring Classifications of Patents Returned From A Search of 10681116 on March 17, 2004

Original Classifications

- 3 348/351
- 2 257/797
- 2 313/413
- 2 324/751
- 2 347/55

Cross-Reference Classifications

- 5 348/356
- 2 250/201.7
- 2 257/620
- 2 313/414
- 2 348/355
- 2 361/225
- 2 396/89

Combined Classifications

- 5 348/356
- 3 348/351
- 2 250/201.7
- 2 250/396R
- 2 250/492.2
- 2 257/620
- 2 257/797
- 2 313/413
- 2 313/414
- 7 212/414
- 2 324/751
- 2 347/55
- 2 348/354
- 2 348/355
- 2 361/225
- 2 396/89
- 2 716/4

10681116 CLSTITLES

Titles of Most Frequently Occurring Classifications of Patents Returne d

From A Search of 10681116 on March 17, 2004

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5 348/356
                 (0 OR, 5 XR)
                348 : TELEVISION
       Class
                     CAMERA, SYSTEM AND DETAIL
        348/207.99
        348/335
                      .Optics
        348/345
                      .. Focus control
                      ... Using image signal
        348/349
                      .... By analyzing high frequency component
        348/354
                      .... Detection of peak or slope of image signa
        348/356
3 348/351
                (3 OR, 0 XR)
                348 : TELEVISION
        Class
                     CAMERA, SYSTEM AND DETAIL
        348/207.99
        348/335
                     .Optics
        348/345
                      .. Focus control
        348/349
                      ... Using image signal
                      ....With oscillation of lens or sensor to
        348/351
                         optimize error signal
2 250/201.7
                (0 OR, 2 XR)
                250 : RADIANT ENERGY
        Class
                  PHOTOCELLS; CIRCUITS AND APPARATUS
        250/201.1 .Photocell controls its own optical systems ..Automatic focus control
                      ... Based on contrast
        250/201.7
                (1 OR, 1 XR)
2 250/396R
                250 : RADIANT ENERGY
        Class
                      WITH CHARGED PARTICLE BEAM DEFLECTION OR
        250/396R
                         FOCUSSING
2 250/492.2
                 (1 OR, 1 XR)
                250 : RADIANT ENERGY
        Class
                     IRRADIATION OF OBJECTS OR MATERIAL
        250/492.1
        250/492.2
                     .Irradiation of semiconductor devices
2 257/620
                 (0 OR, 2 XR)
                257 : ACTIVE SOLID-STATE DEVICES
        Class
                      PHYSICAL CONFIGURATION OF SEMICONDUCTOR (E.G.,
        257/618
                          MESA, BEVEL, GROOVE, ETC.)
                      .With peripheral feature due to separation of
        257/620
                         smaller semiconductor chip from larger wafe
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region, or means to prevent edge effects su

r (e.g., scribe

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ch as leakage
                          current at peripheral chip separation area)
   257/797
                 (2 OR, 0 XR)
                 257 : ACTIVE SOLID-STATE DEVICES
         Class
          257/797
                       ALIGNMENT MARKS
                  (2 OR, 0 XR)
  2 313/413
                 313 : ELECTRIC LAMP AND DISCHARGE DEVICES
          Class
                       CATHODE RAY TUBE
          313/364
                       .Plural beam generating or control
          313/409
                       ..With deflection
          313/413
                   (0 OR, 2 XR)
  2 313/414
                  313 : ELECTRIC LAMP AND DISCHARGE DEVICES
          Class
                       CATHODE RAY TUBE
          313/364
                        .Plural beam generating or control
          313/409
                        ..With focusing and accelerating electrodes
          313/414
  2 324/751
                   (2 OR, 0 XR)
                  324 : ELECTRICITY: MEASURING AND TESTING
          Class
                        FAULT DETECTING IN ELECTRIC CIRCUITS AND OF
          324/500
                              ELECTRIC COMPONENTS
                        .Of individual circuit component or element
          324/537
                        .. System sensing fields adjacent device under
          324/750
                            test (DUT)
                        ... Using electron beam probe
          324/751
  2 347/55
                  (2 OR, 0 XR)
                  347 : INCREMENTAL PRINTING OF SYMBOLIC INFORMATION
          Class
                        INK JET
          347/1
                        .Ejector mechanism (i.e., print head)
          347/20
                        ..Drop-on-demand
          347/54
                        ...With electric field ejection (applied to
          347/55
                           fluid)
  2 348/354
                   (1 OR, 1 XR)
                  348 : TELEVISION
          Class
          348/207.99 CAMERA, SYSTEM AND DETAIL
          348/335
                        .Optics
                        .. Focus control
          348/345
                        ... Using image signal
          348/349
                        .... By analyzing high frequency component
          348/354
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	348/207 348/335	348 .99	: TELEVISION CAMERA, SYSTEM AND DETAIL .OpticsFocus controlUsing image signal
2	361/225 Class		OR, 2 XR) : ELECTRICITY: ELECTRICAL SYSTEMS AND DEVICES
	361/225		ELECTRIC CHARGING OF OBJECTS OR MATERIALS
2	396/89 Class 396/89	396	: PHOTOGRAPHY
2		716	OR, 1 XR) : DATA PROCESSING: DESIGN AND ANALYSIS OF CIRCUIT OR SEMICONDUCTOR MASK CIRCUIT DESIGN .Testing or evaluating